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# Influence of Molecular Adsorption on MoS<sub>2</sub> Memtransistor Switching Kinetics

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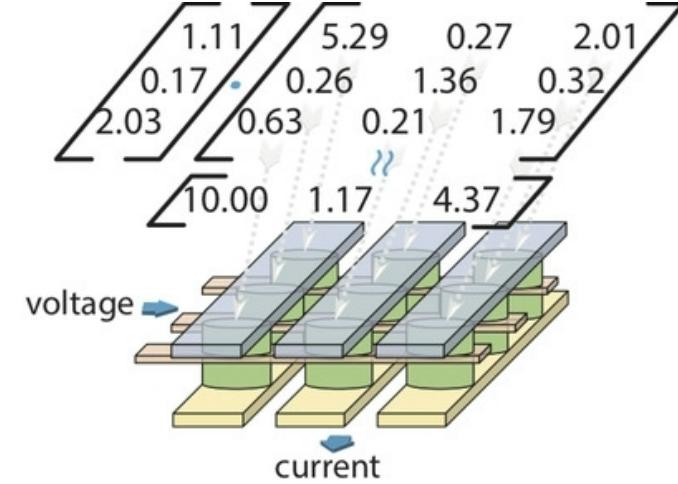
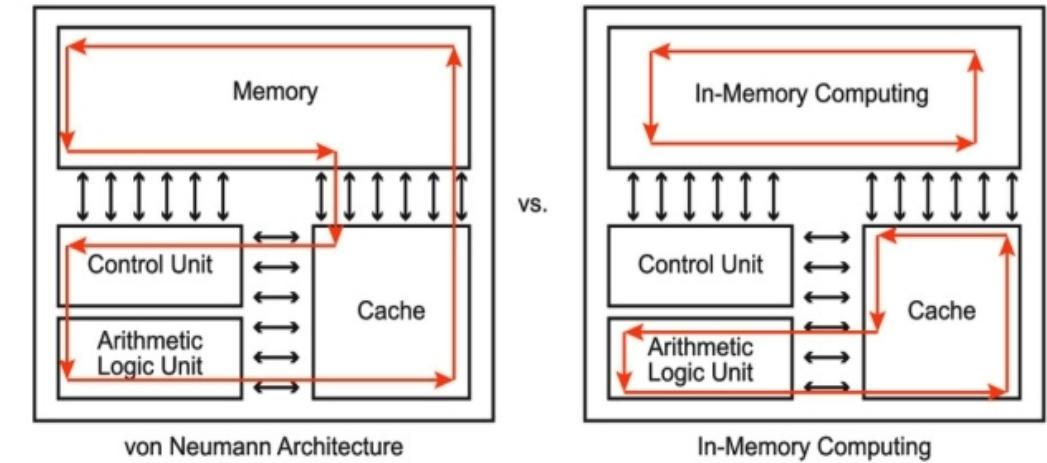
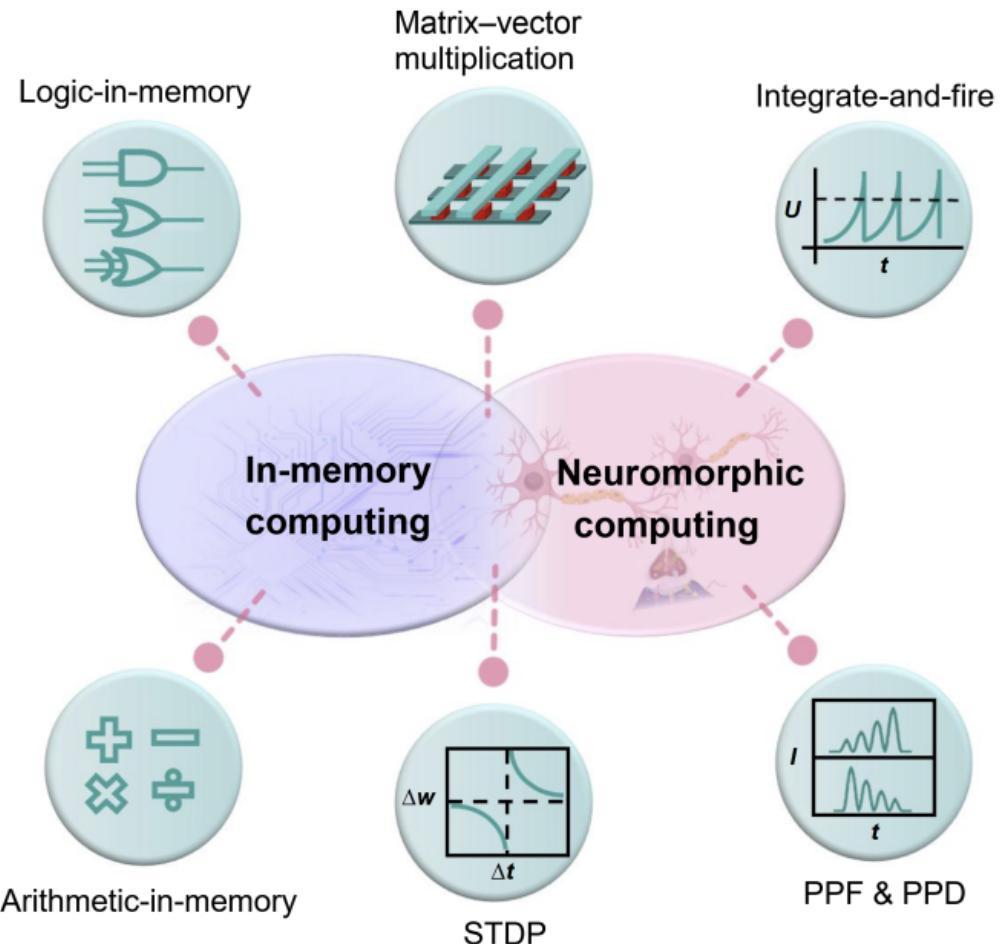


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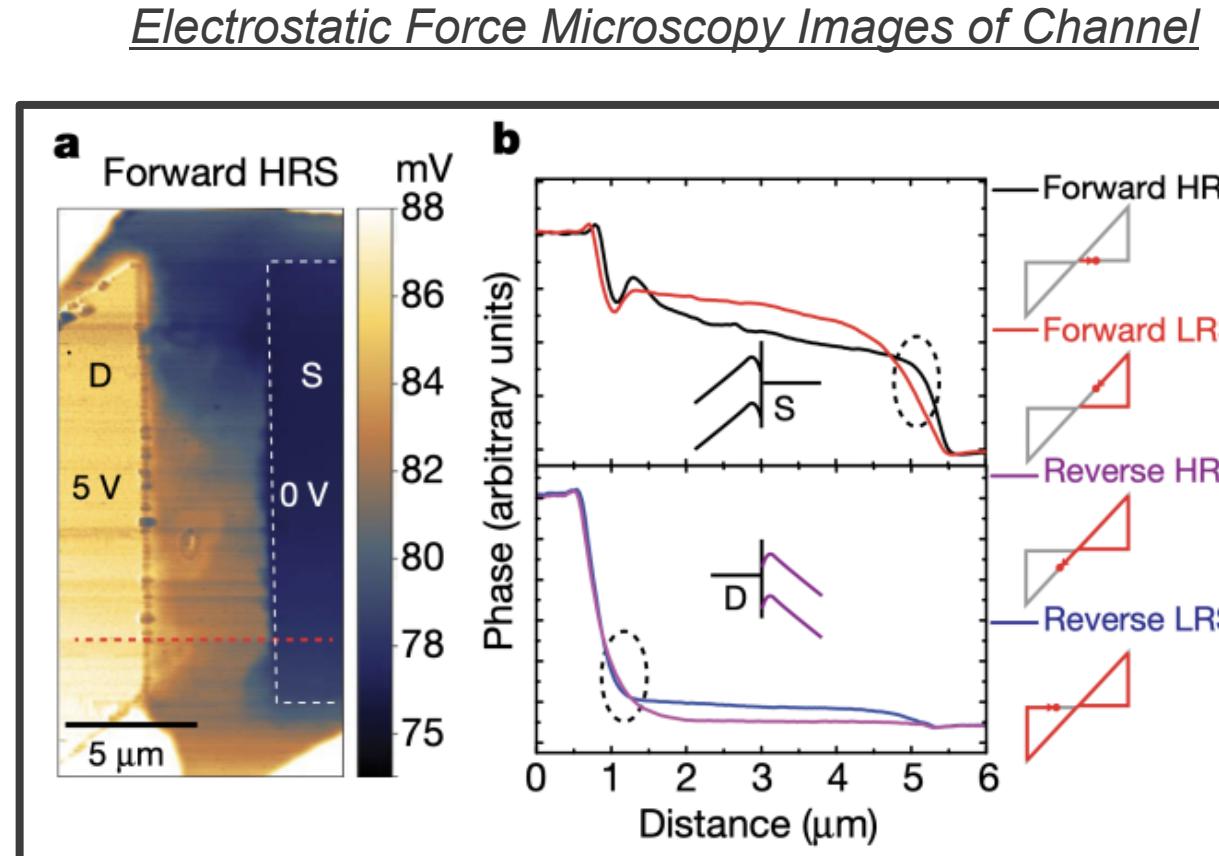
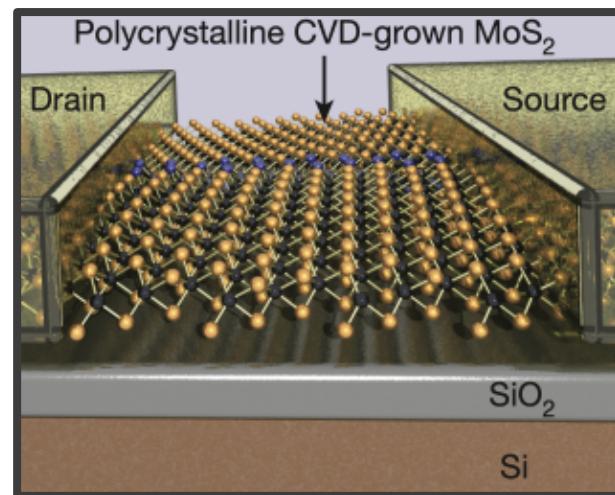
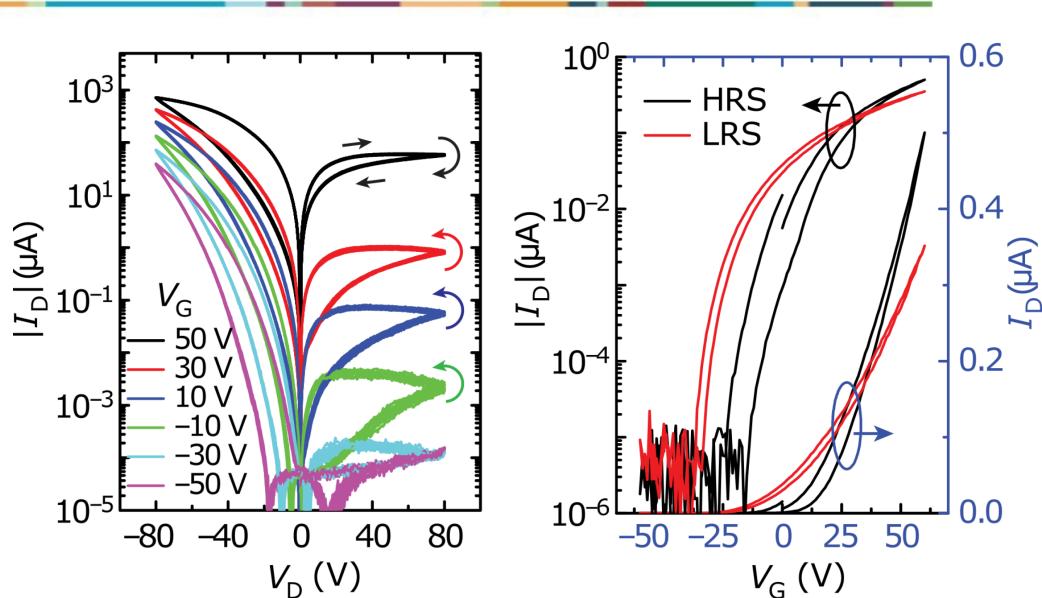
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# Memristive Circuits Yield More Efficient Computing

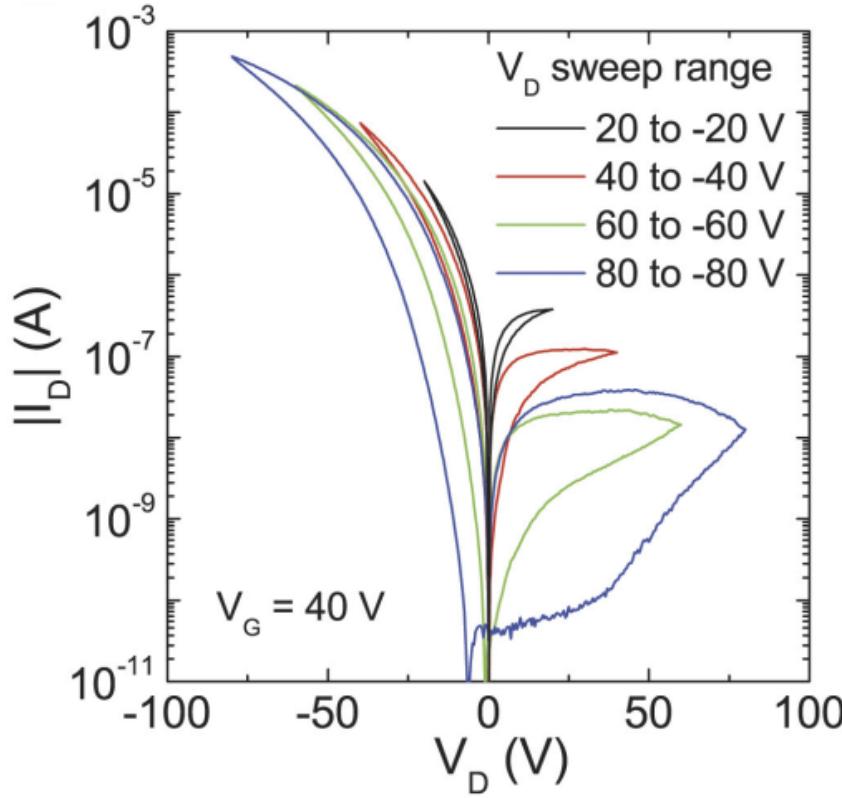


# MoS<sub>2</sub> ‘Memtransistors’ Utilize a Hysteretic SBH

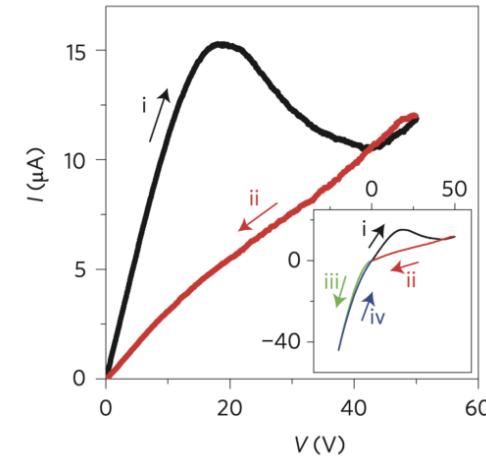
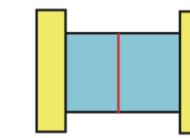
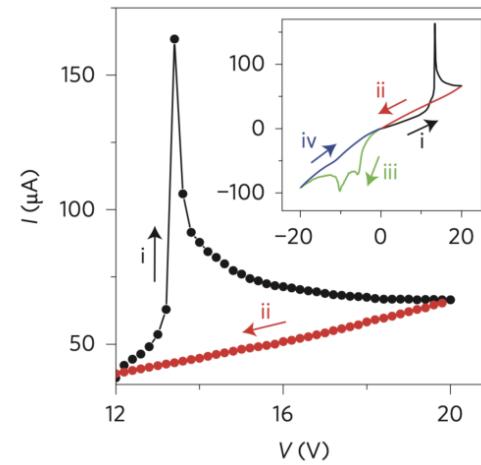
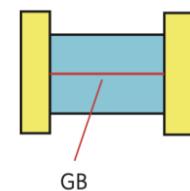


# Goal: Lower Set Voltages by Modifying $V_s$ migration kinetics

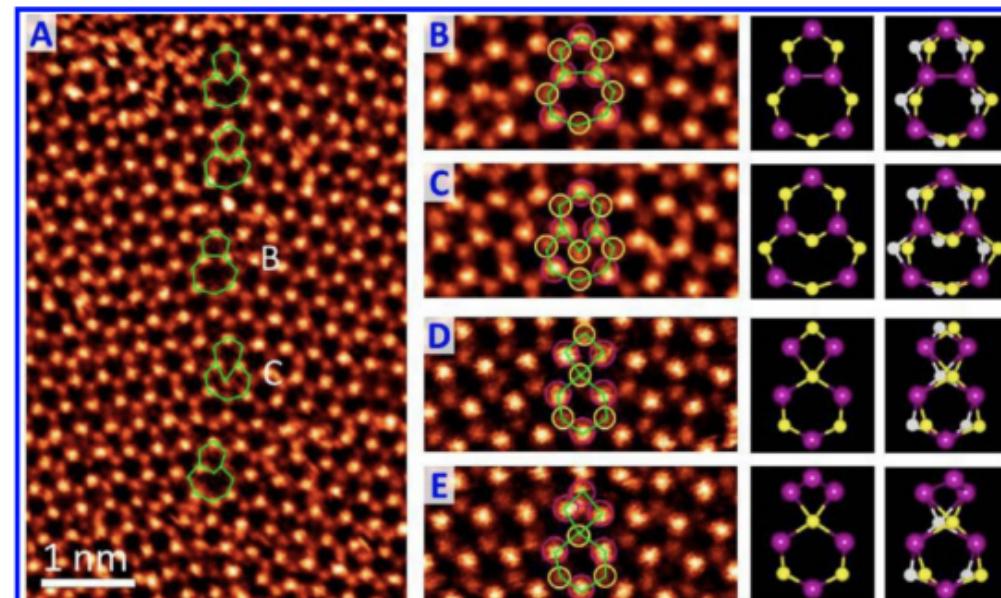
Memory Switching is Modest at  $V_{ds} < 50$  V



Sangwan et al. *Nature* 2018, 500-504.



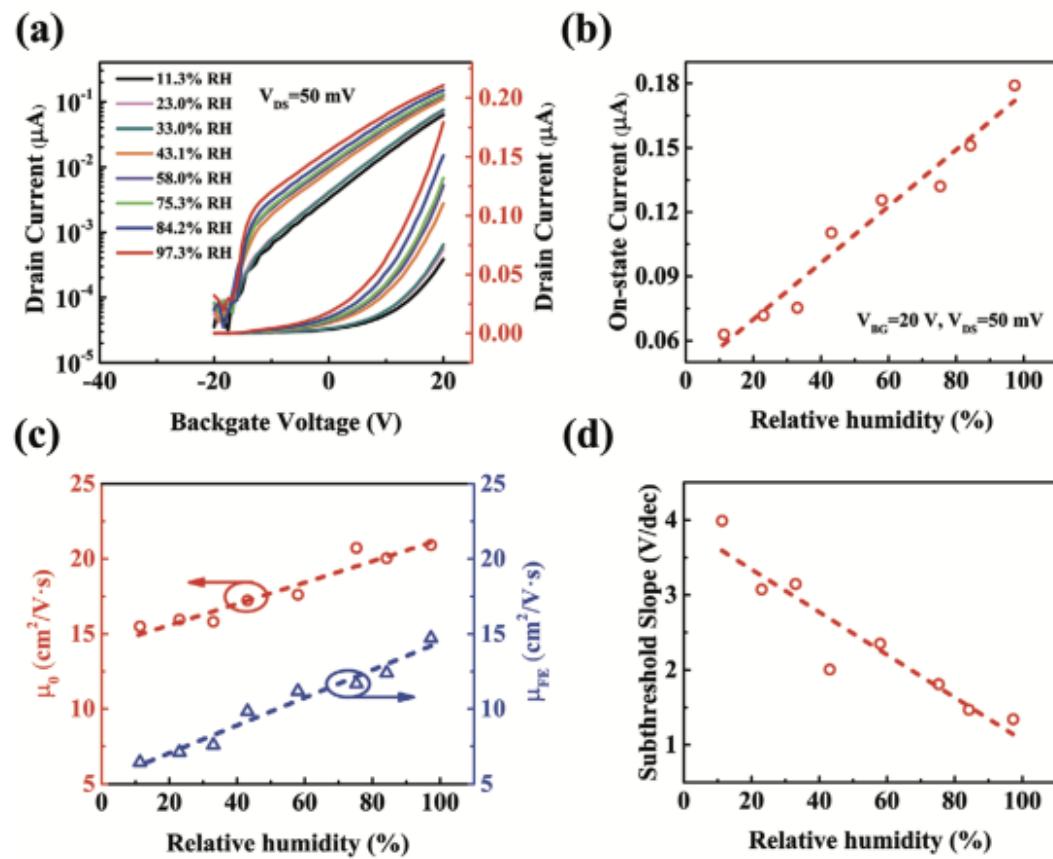
Sangwan et al. *Nat. Nanotechnol.* 2015, 403-406.



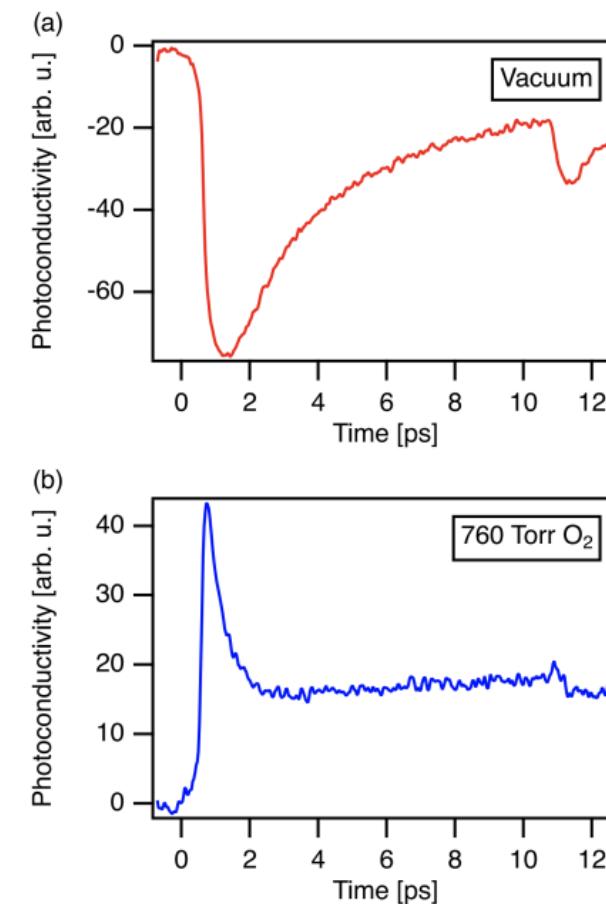
Zhou et al. *Nano Lett.* 2013, 2615-2622.

# Adsorbed Molecules Alter Transport Properties in $\text{MoS}_2$

## Adsorbed Water Dopes $\text{MoS}_2$ Film

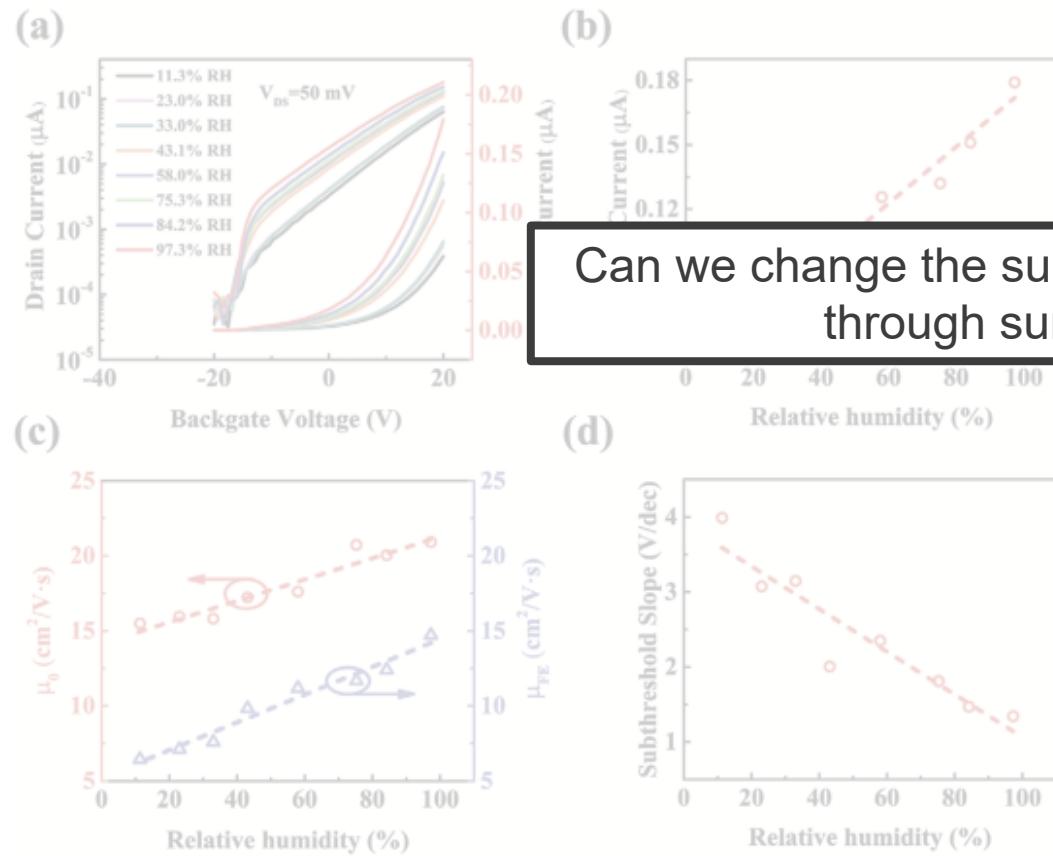


## Adsorbed $\text{O}_2$ Changes Photoconductivity

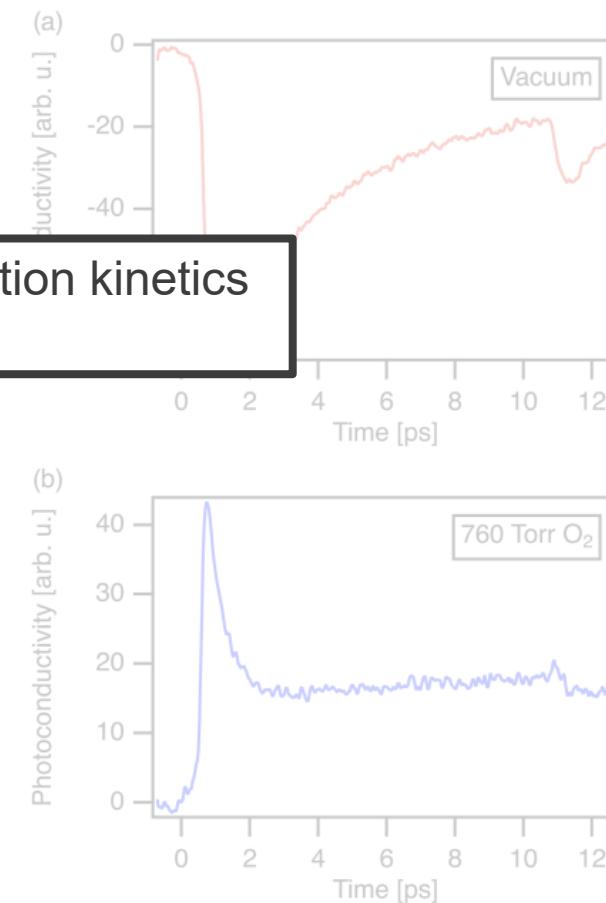


# Adsorbed Molecules Alter Transport Properties in $\text{MoS}_2$

## Adsorbed Water Dopes $\text{MoS}_2$ Film



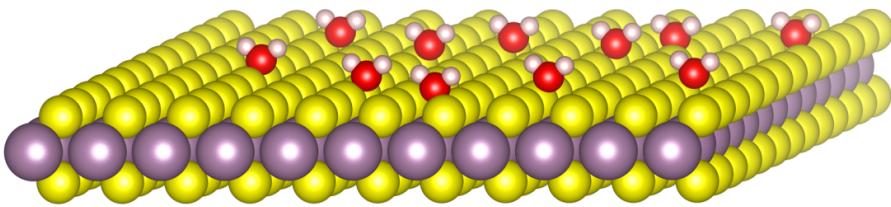
## Adsorbed $\text{O}_2$ Changes Photoconductivity



Can we change the sulfur vacancy migration kinetics through surface interactions?

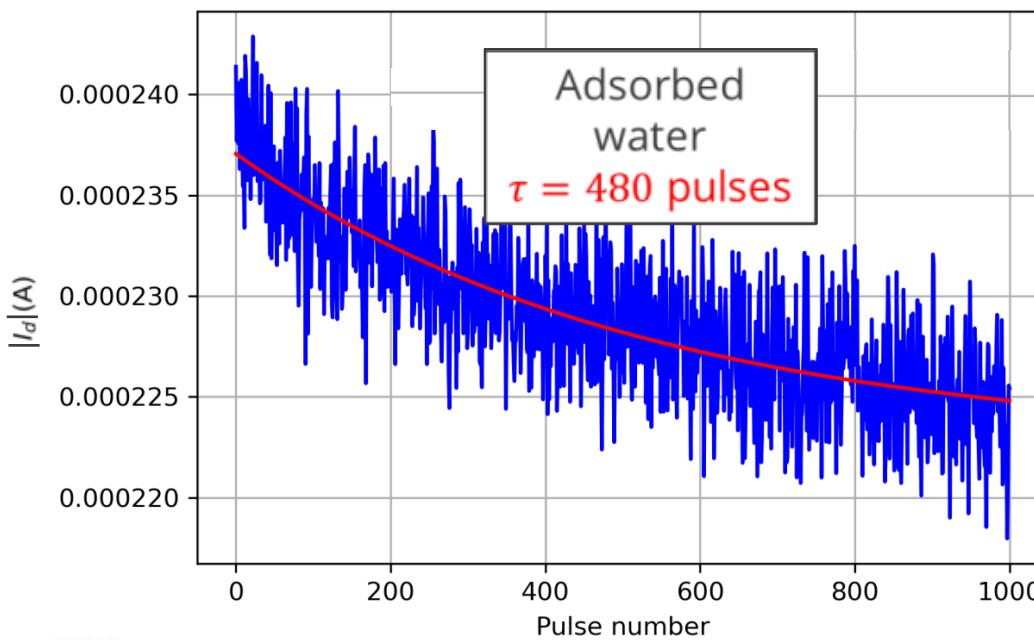
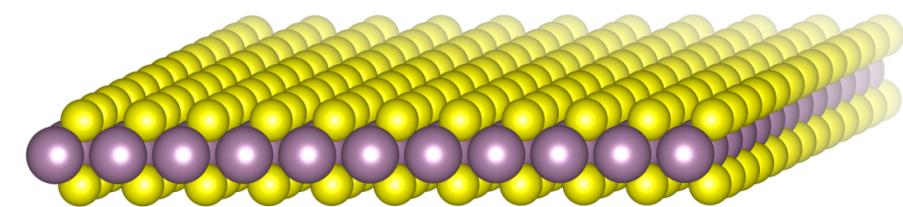
# Adsorbed Molecules Suppress a Fast-Switching Process

Molecules adsorbed to surface:

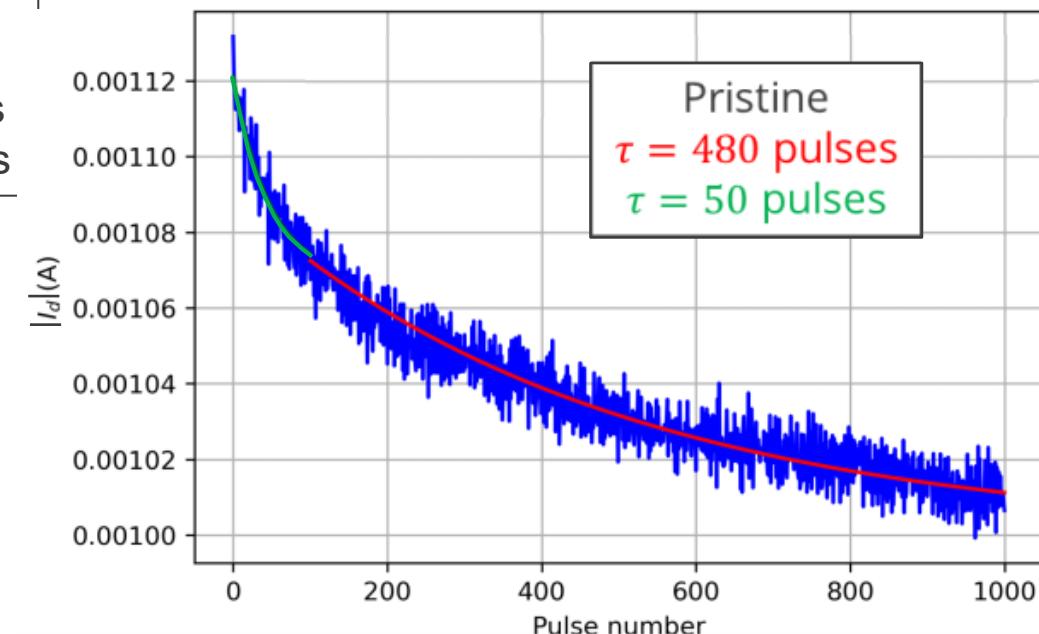


Bake out @ 100°C in vacuum  
for 15 min.

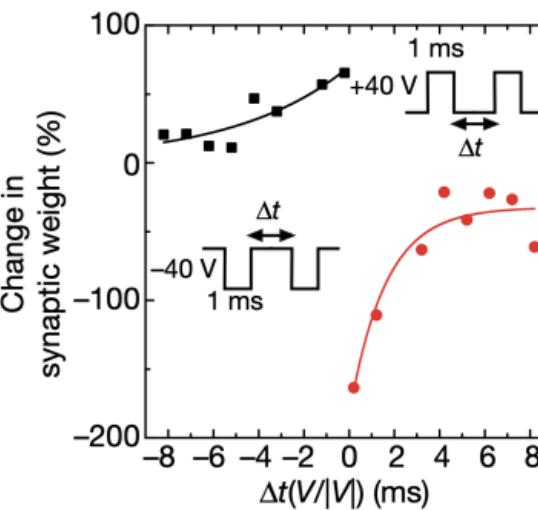
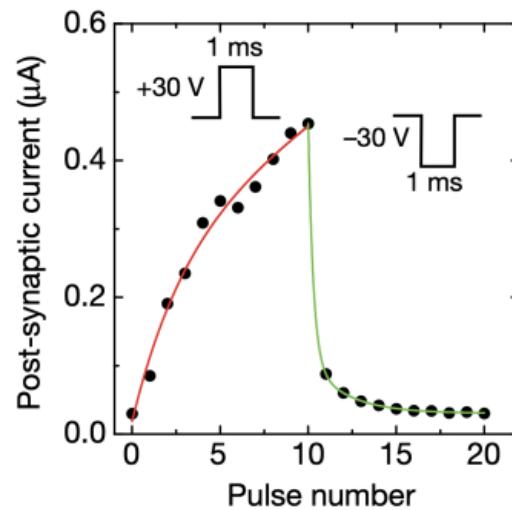
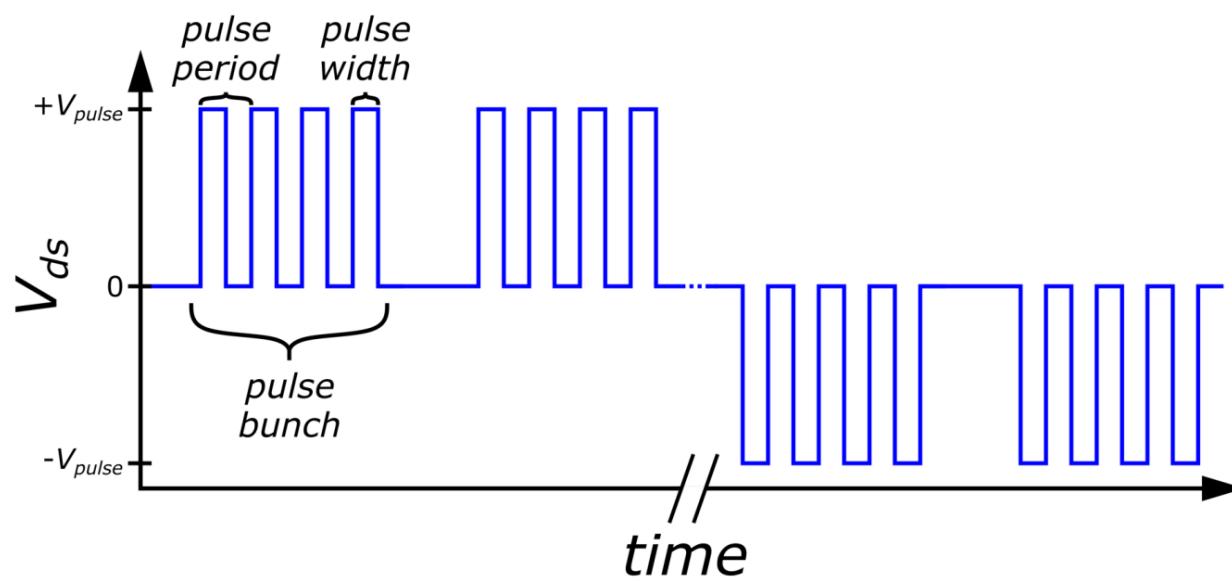
Pristine MoS<sub>2</sub> surface:



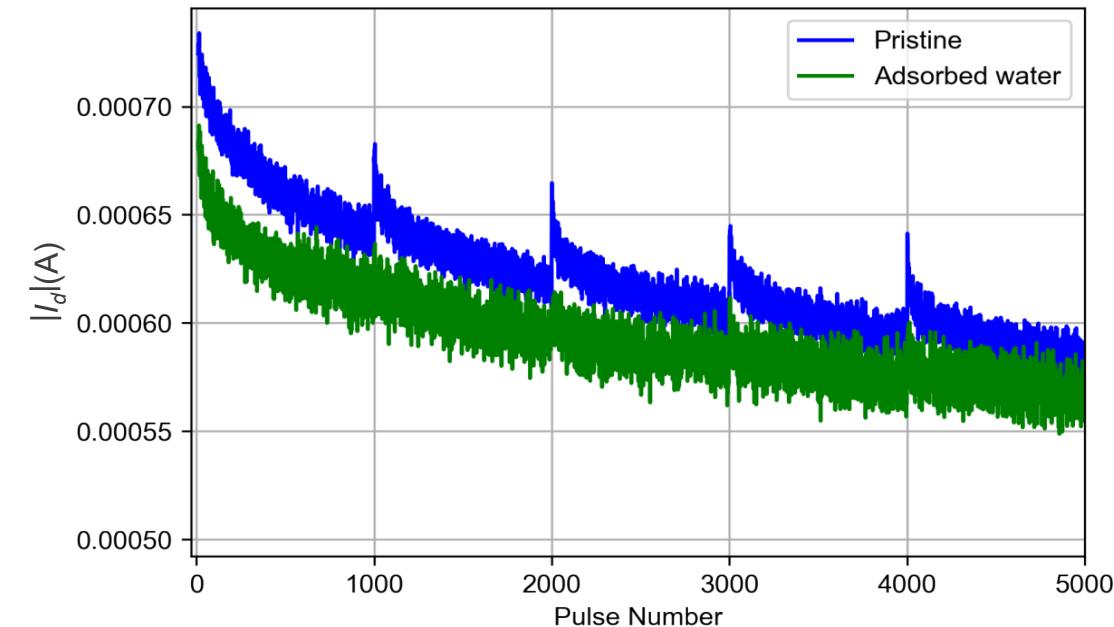
$$\begin{aligned}V_{ds} &= -20 \text{ V} \\V_{gs} &= 0 \text{ V} \\t_{pulse} &= 10 \text{ ms} \\t_{period} &= 20 \text{ ms}\end{aligned}$$



# Pulse Bunching Allows Separation of Fast and Slow Processes

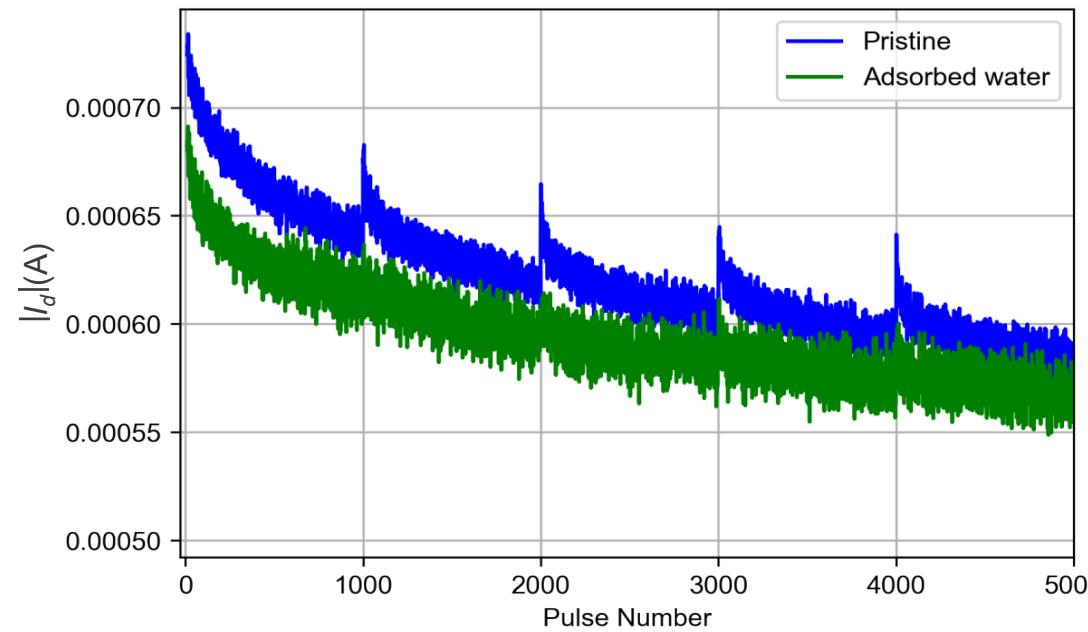


$V_{ds} = -20\text{ V}$ ,  $V_{gs} = 0\text{ V}$ ,  $t_{pulse} = 10\text{ ms}$ ,  $n_{pulse} = 1000$

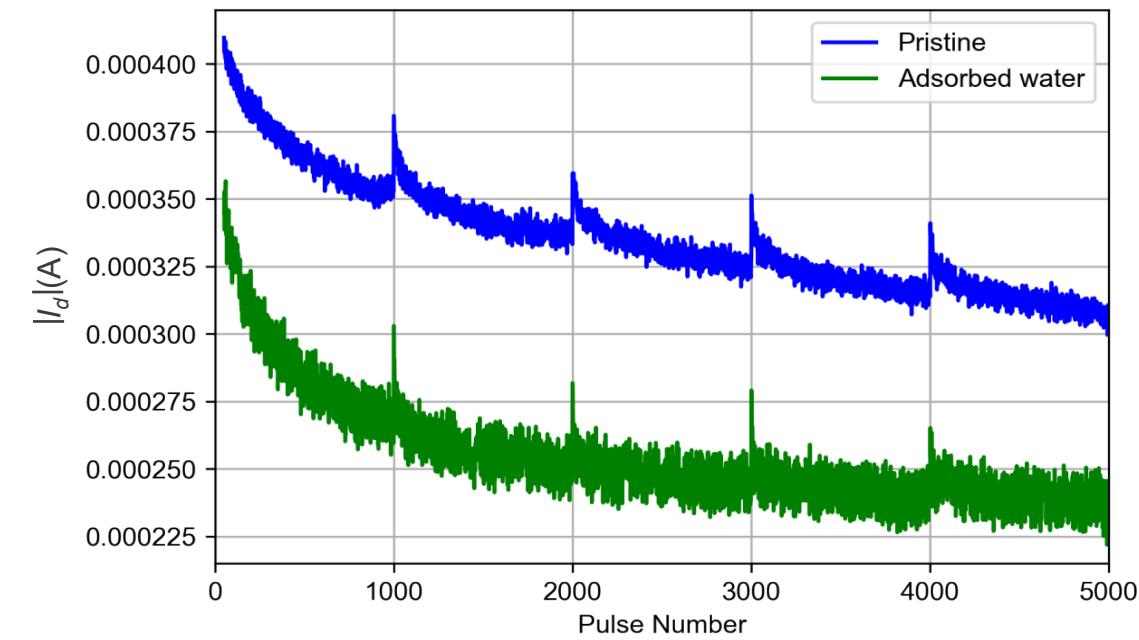


# Application of $V_{gs} < 0$ Attenuates Transient Suppression

$V_{ds} = -20 \text{ V}$ ,  $V_{gs} = 0 \text{ V}$ ,  $t_{pulse} = 10 \text{ ms}$ ,  $n_{pulse} = 1000$



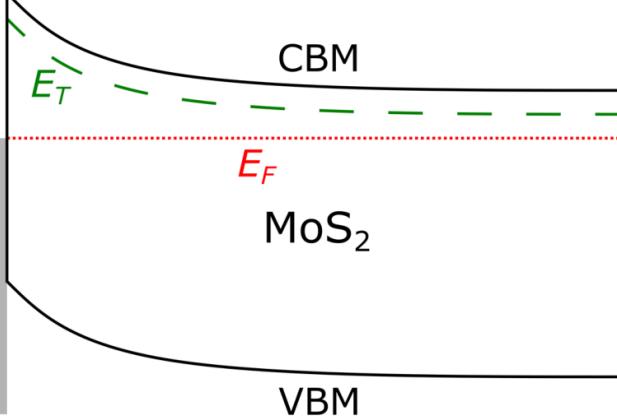
$V_{ds} = -20 \text{ V}$ ,  $V_{gs} = -60 \text{ V}$ ,  $t_{pulse} = 10 \text{ ms}$ ,  $n_{pulse} = 1000$



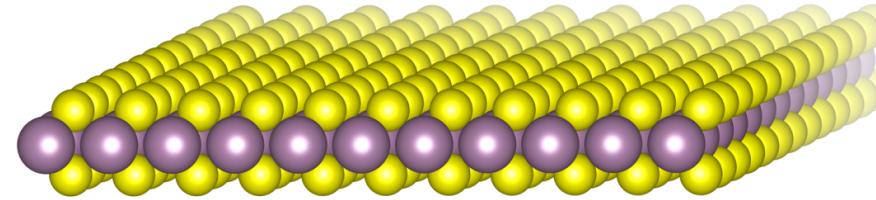
# Gate-dependence Suggests Adsorption Changes Trap Energy

Gate bias = 0 V

Drain (Ti)

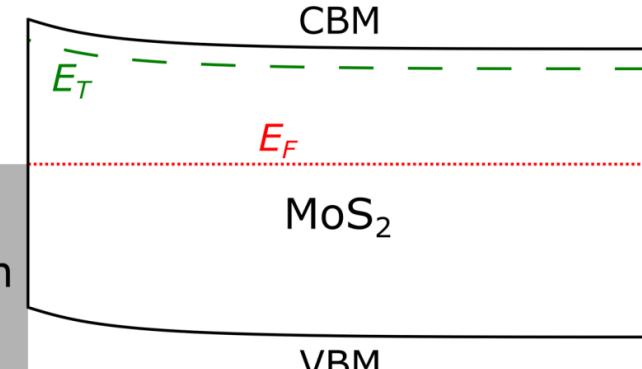


Pristine  $\text{MoS}_2$  surface:



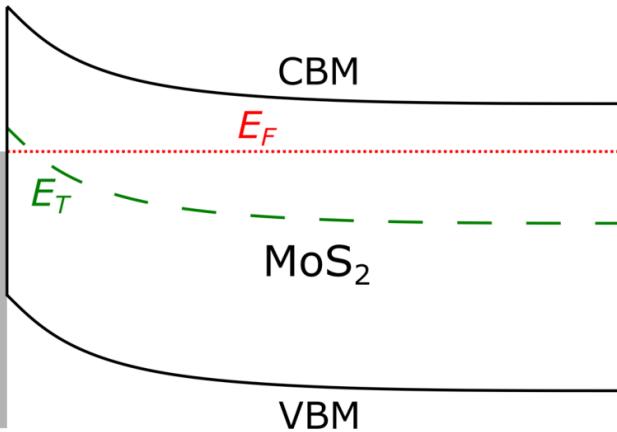
Gate bias = -60 V

Drain (Ti)

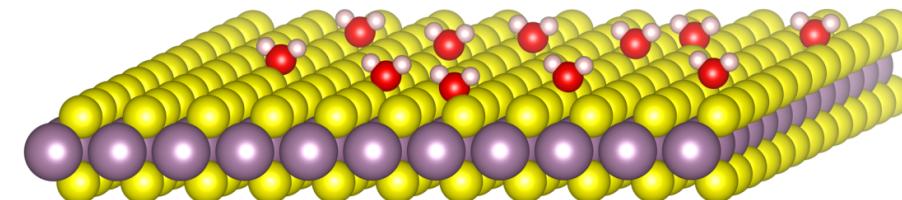


Gate bias = 0 V

Drain (Ti)

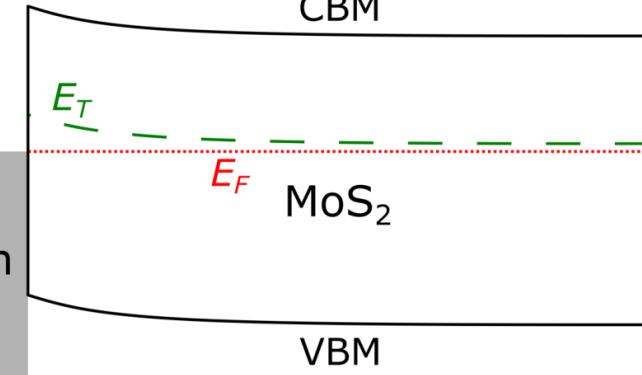


Adsorbed to surface:

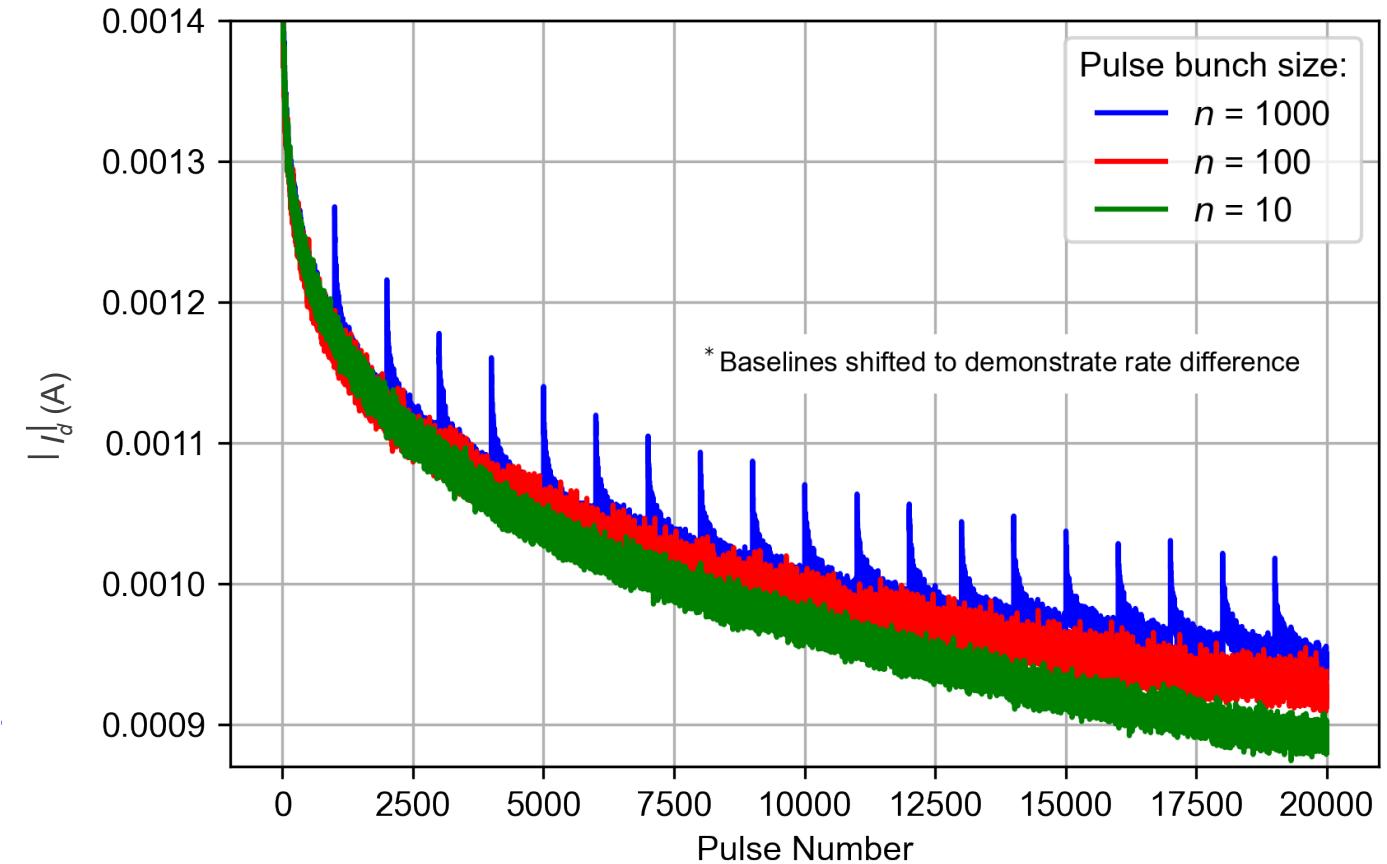
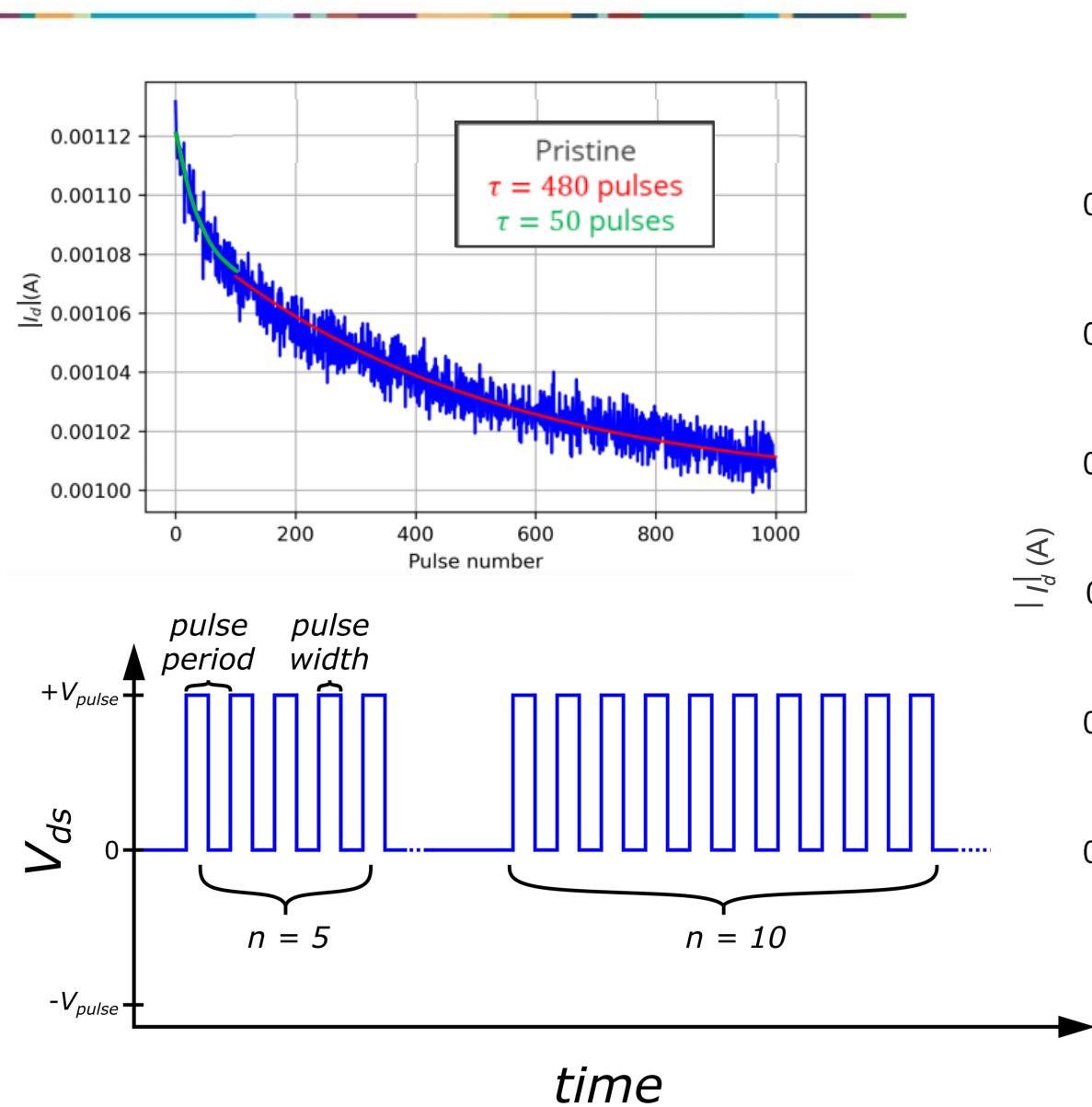


Gate bias = -60 V

Drain (Ti)

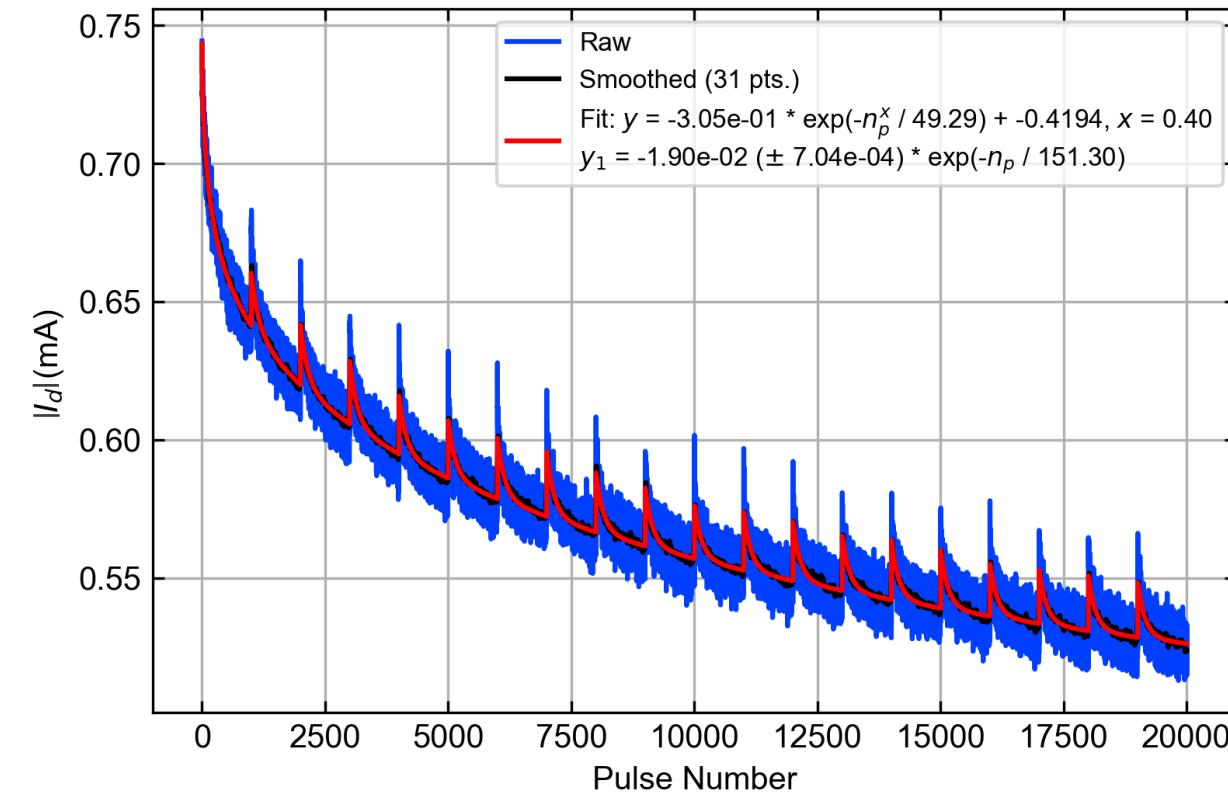


# Persistent Switching Rate Depends on Trap Occupation

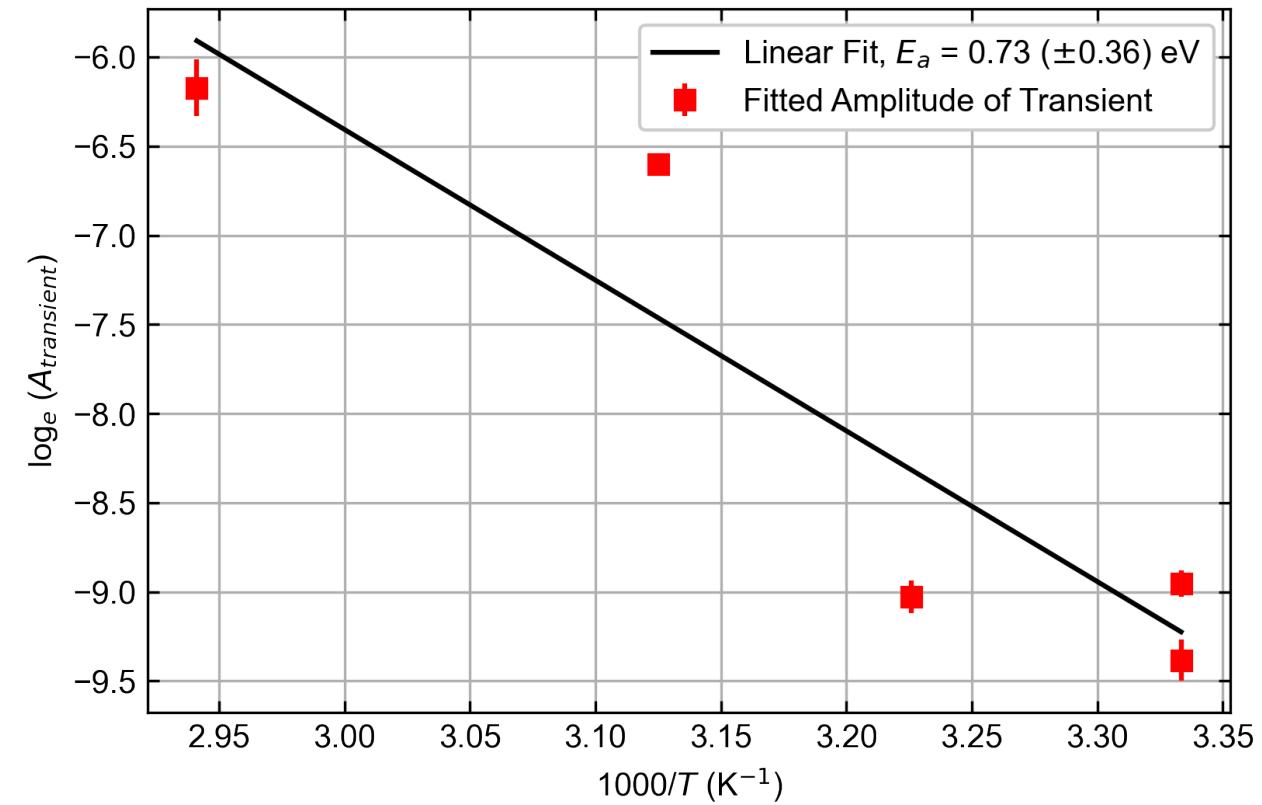


# VT Pulsing Indicates Deep Level Trap Responsible

$V_{ds} = -20 \text{ V}$ ,  $V_{gs} = -20 \text{ V}$ ,  $t_{pulse} = 10 \text{ ms}$ ,  $n_{pulse} = 1000$

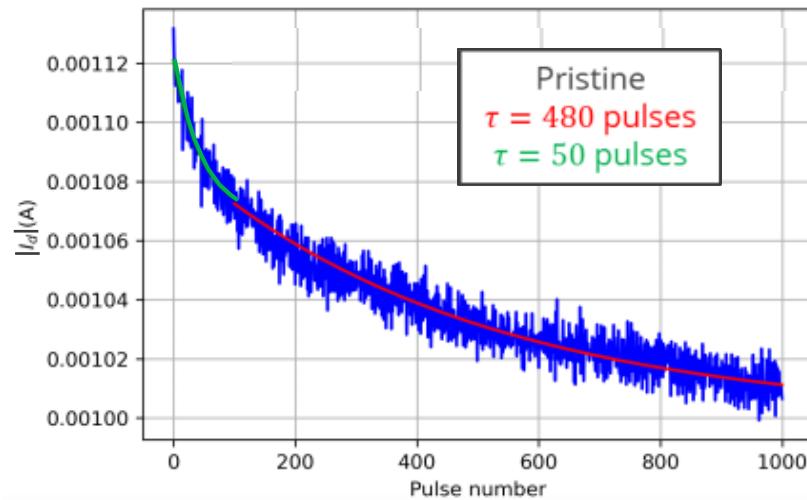


$A_{transient}$  at 300 K, 310 K, 320 K, & 340 K (pristine)

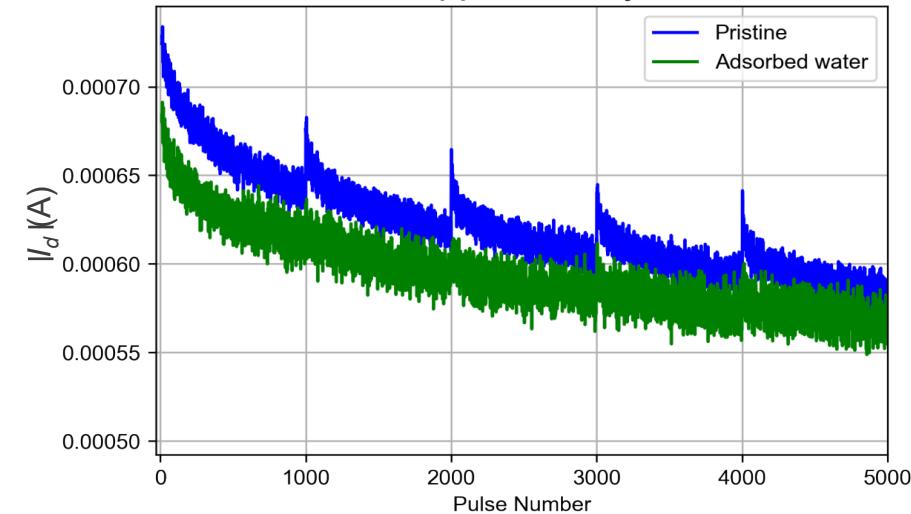


# Conclusions

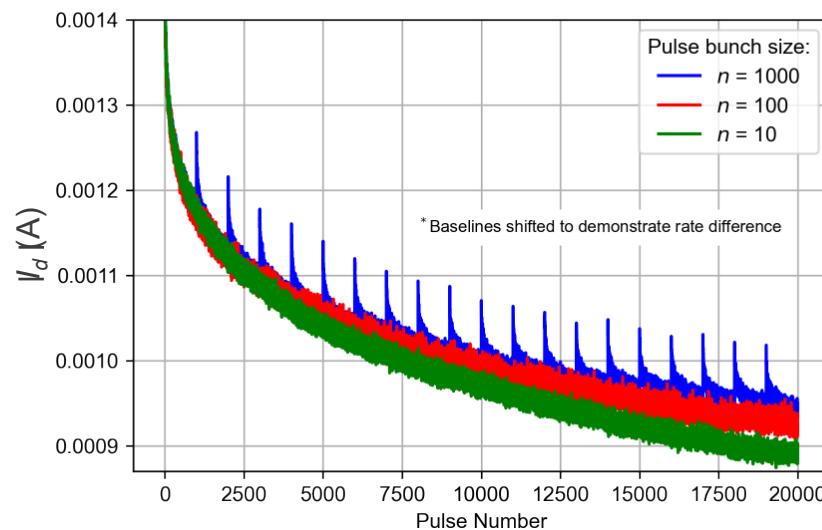
## Switching Process Consists of Fast and Slow Processes



## Fast Process Can be Suppressed by Adsorbed Molecules



## Occupancy of Traps Changes Persistent Switching Rate



## Trap State Responsible Lies Relatively Deep in Band Gap

